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Sheet 1 of 2

Complete if Known					
Application Number	10/603,304				
Filing Date	June 25, 2003				
First Named Inventor	Miyuki MATSUYA				
Group Art Unit	2881				
Examiner Name	Not Yet Assigned				
Attorney Docket Number	0116-031009				

U.S. PATENT DOCUMENTS							
	Cite No.1	U.S. Patent Document Number Kind Code ²		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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FOREIGN PATENT DOCUMENTS								
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INFOR	KMAHOI	N DISCLO	SURE	Application Number	10/603,304	
STATE	MENT	BY APPLI	CANT	Filing Date	June 25, 2003	
OTATEMENT BY ALL EIGHT				First Named Inventor	Miyuki MATSUYA	
(use as many sheets as necessary)				Group Art Unit	2881	
				Examiner Name	Not Yet Assigned	
Sheet	2	of	2	Attorney Docket Number	0116-031009	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, cite and/or country where published.	T²			
P6		VON H. ROSE, <i>OPTIK 33,</i> Heft 1, 1971, pages 1-24.				
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Pb		JOACHIM ZACH ET AL., "Aberration correction in a low voltage SEM by a multipole corrector", Nucl. Instr. and Meth. in Phys. Res. A 363 (1995), pages 316-325.				
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